

2814



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Atty. Docket

TED LETAVIC ET AL

US 010631

Serial No. 10/015,640

Group Art Unit: 2814

Filed: DECEMBER 10, 2001

Examiner: N. V. NGO

#4a
D. Scott
8-28-02

Title: HIGH FREQUENCY HIGH VOLTAGE SILICON-ON-INSULATOR DEVICE
WITH MASK VARIABLE INVERSION CHANNEL LAND METHOD FOR FORMING
THE SAME

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the official Office Action dated July
15, 2002, please amend the above-identified application as
follows:

IN THE CLAIMS

Kindly cancel Claims 14-20 without prejudice

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REMARKS

In the outstanding Official Action, restriction was
required as between Claims 1-13, drawn to a semiconductor
device and Claims 14-20, drawn to process for making a
semiconductor device.

In response, Applicants hereby elect Claims 1-13 for
an examination on the merits, without prejudice to Applicants'